



Docket No.:0756-7244 JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Koichiro TANAKA, et al.)
Serial No. 10/749,505) Group Art Unit: 2828
Filed: January 2, 2004) Examiner: A. Rodriguez
For: LASER IRRADIATION METHOD, METHOD)
FOR MANUFACTURING SEMICONDUCTOR)
DEVICE, AND LASER IRRADIATION SYSTEM)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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Henry J. Robinson

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789
(571) 434-9499 (Fax)